

Docket No.: 4684-010



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Inventor(s): Heui-Jae PAHK et al. : Confirmation No. 2498
U.S. Patent Application No. 10/501,381 : Group Art Unit: 2877
Filed: July 15, 2004 : Examiner:
For: MACHINE AND METHOD FOR INSPECTING FERRULE OF OPTICAL
CONNECTOR

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

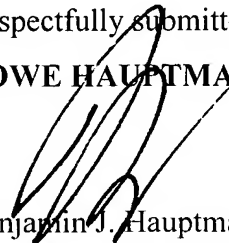
Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

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4684-010U.S. PATENT
APPLICATION NO.
10/501,381APPLICANT
Heui-Jae PAHK et al.FILING DATE
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2877

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	1999-025138	4/1999	Korea			X	
	08-029642	2/1996	Japan			X	
	61-221632	10/1986	Japan			X	
	00269263	7/2000	Korea			X	
	00198817	3/1999	Korea			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.